

## **METHOD OF DEFECT ROOT CAUSE ANALYSIS**

Appl. No. : 10/708,943 Confirmation No. 2942  
Applicant : Long-Hui Lin  
Filed : April 2, 2004  
TC/A.U. : 2857  
Examiner : TSAI, CAROL S W  
Docket No. : LKSP0028USA  
Customer No. : 27765

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

## **AMENDMENT**

5 Sir:

In response to the Office action of June 20, 2008, please amend the above-identified application as follows:

**Remarks/Arguments** begin on page 2 of this paper.